



<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449</b>	Docket No. <b>52433/795</b>	Application No. <b>10/534,858</b>	
	Applicant(s) <b>M. HASHIMURA et al.</b>	Examiner <b>Deborah Yee</b>	
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## U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE

## FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
	JP 61-104049	May 22, 1986	JP			Abstract	
	JP 07-034189	February 3, 1995	JP			Abstract	
	JP 11-293391	October 26, 1999	JP			Abstract	
	JP 2001-329335	November 27, 2001	JP			Abstract	
	JP 2000-034538	February 2, 2000	JP			Abstract	

## OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
	Japanese Office Action dated May 20, 2008 issued in corresponding Japanese Application No. 2002-332668.
	Japanese Office Action dated May 20, 2008 issued in corresponding Japanese Application No. 2002-332658.

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	